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APPLICANTS

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CROSSING DATA

This application is a 371 of PCT/JP03/02568 03/05/2003

FOREIGN APPLICATIONS

JAPAN 2002-261286 09/06/2002
JAPAN 2002-059182 03/05/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
Verified and Acknowledged Examiner's Signature: Initials:					

ADDRESS

00909

TITLE

Process for producing silicon single crystal layer and silicon single crystal layer

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